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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *Ad*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2002-84281 12/26/2002

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IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 8	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Ad</i>				
Verified and Acknowledged	Examiner's Signature	Initials		

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## TITLE

Method of forming isolation films in semiconductor devices

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
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